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In re application of

: Confirmation No. 6560

Junji KUNISAWA et al.

Docket No. 2003 1074

Serial No. 10/629,678

Group Art Unit 1746

Filed July 30, 2003

Examiner Joseph L. Perrin

HOLDING UNIT, PROCESSING APPARATUS AND HOLDING METHOD OF SUBSTRATES

Mail Stop: Amendment

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of June 29, 2004, the period for response to which having been extended by one month to October 29, 2004, please amend the above-identified U.S. Patent application as follows: